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Mullish

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: )  
TSUGANE et al. )  
Serial No. 09/759,915 )  
Filed: January 13, 2001 )  
For: SEMICONDUCTOR DEVICES AND METHODS )  
FOR MANUFACTURING THE SAME )

Group Art Unit: 2813

Examiner: Nguyen, Tuan H.

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AMENDMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sirs:

In response to the Office Action dated May 17, 2002, the time for response being extended three months by the enclosed petition for extension of time, please enter and consider the following:

IN THE SPECIFICATION:

Please delete the first paragraph, starting at page 1, line 6 and ending at page 1, line 16, and insert the following in its place:

--Reference to Cross-Related Applications

A1 Japanese patent application no. 2000-5335, filed January 14, 2000, is hereby incorporated by reference in its entirety. U.S. Patent Application Serial No. 09/759,665, filed on January 13, 2001, is hereby incorporated by reference in its entirety. U.S. Patent Application Serial No. 09/759,666, filed on January 13, 2001, is hereby incorporated by reference in its entirety. U.S. Patent Application Serial No. 09/759,715, filed on January 13, 2001, is hereby incorporated by reference in its entirety.--

IN THE CLAIMS:

✓  
Please cancel claims 5-14 without prejudice.

Please amend claims 1-2 to read as follows: